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P/4178-9

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Masanobu SATO et al.

Serial No.: 10/669,520

Filed: September 24, 2003

Confirmation No.: 4349

Date: May 3, 2006

Group Art Unit: 1734

Examiner: Yewebdar T. Tadesse

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING SYSTEM

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of two Office Actions issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in communications from a foreign patent office in a counterpart foreign application and that this communication was not received by any individual designated in 37 C.F.R. 1.56(c) more than 30 days prior to the filing of this Submission.

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James A. Finder

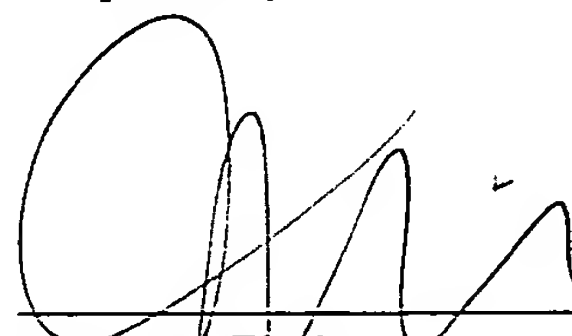
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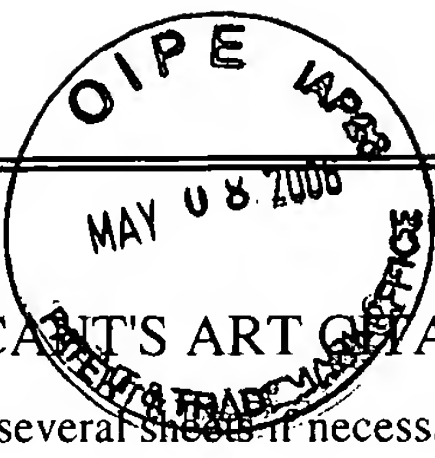
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Enclosures

Respectfully submitted,



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APPLICANT'S ART CITATION

(Use several sheets if necessary)

Application 10/669,520

OFGS File No. P/4178-9

Applicant
Masanobu SATO et al.

Filing Date
September 24, 2003

Group Art Unit
1734

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	10-116805	05-1998	Japan			X	
	2001-223195	08-2001	Japan			X	
	6-151398	05-1994	Japan			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Japanese Office Action issued April 17, 2006
	Japanese Office Action issued April 17, 2006

Examiner

Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.